Supporting information

Waterbeds inspired stress relaxation strategies of patterned silicon anode to realize the fast-charging and longevity lithium microbatteries

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Average size	30-mesh	100-mesh	250-mesh
(µm)			
Square pore	500	200	50
Wire array	150	50	10

Table S1. The detailed size of various mesh of the copper microgrids used in this study.

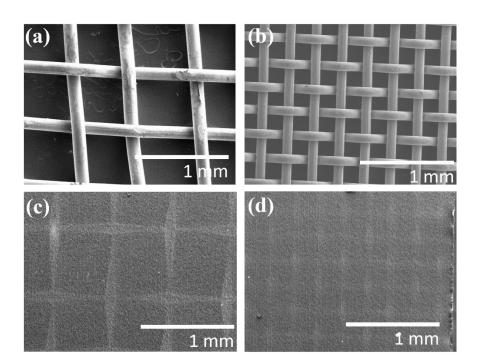


Figure S1. SEM images showing topography of the copper microgrid: (a) 30 Mesh, (b)

100 Mesh, and corresponding patterned Si of (c) P-Si30M, (d) P-Si100M.

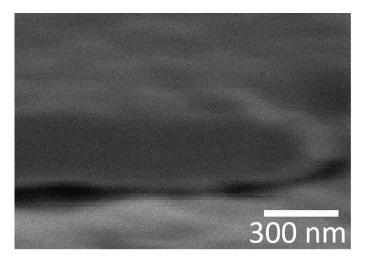


Figure S2. The cross-section SEM image of P-Si250 M electrode.

	1 st lithiation	1 st delithiation capacity (mAh/g)	ICE (%)	Retention (%)
	capacity (mAh/g)			
A-Si	3424.5	2993.7	87.4	9.1
P-Si30M	2440.8	2049.3	84.0	21.6
P-Si100M	2829.2	2164.3	76.5	36.4
P-SI250M	2665.9	2028.8	76.1	46.6

Table S2. The lithiation/delithiation capacity, ICE of 1st cycle, and the capacity retention after 200 cycles at 1 C rate correspond to each electrode.

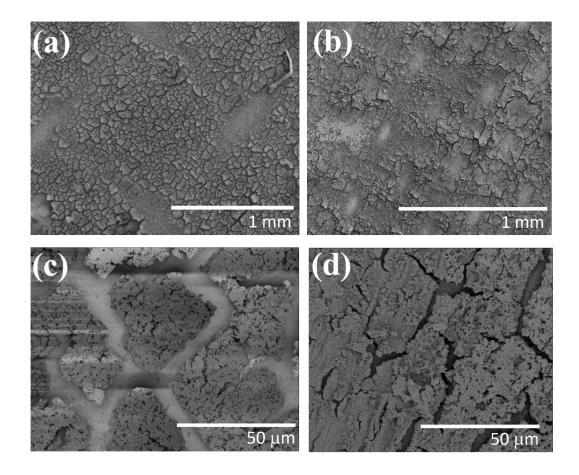


Figure S3. SEM images showing topography of the disassembled patterned Si electrodes at low-magnification 50x and high-magnification 1000x for (a, c) P-Si30M, (b, d) P-Si100M.

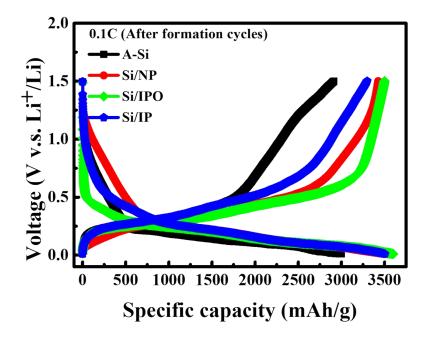


Figure S4. The charge/discharge curves at 0.1 C after formation cycles.

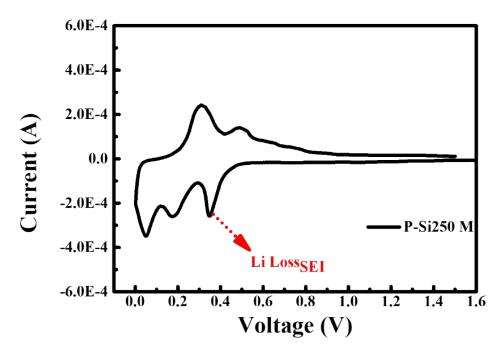


Figure S5. 1st cycle CV curves at a scan rate of 0.1 mV/s of P-Si250 M patterned Si electrode.

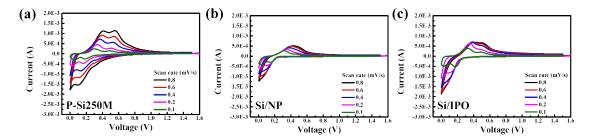


Figure S6. CV curves at different voltage scan rates from 0.1 to 0.8 mV/s: (a) P-Si250 M, (b) Si/NP, and (c) Si/IPO electrodes.

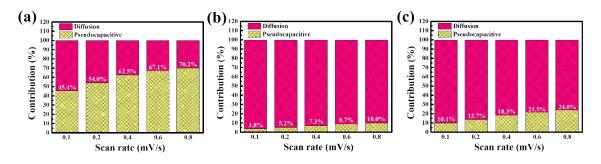


Figure S7. Contribution ratio of the pseudocapacitive and diffusion controlled charge versus scan rate: (a) P-Si250 M, (b) Si/NP, and (c) Si/IPO electrodes.